## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Walter SCHWARZENBACH et al Confirmation No.: 3337

Application No.: 10/766,207 Group Art Unit: 2822

Filing Date: January 29, 2004 Examiner: Khanh B. Duong

For: METHOD OF DETACHING A LAYER FROM A

WAFER USING A LOCALIZED STARTING

**AREA** 

## **AMENDMENT**

Attorney Docket No.: 4717-11600

Mail Stop AF

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the final Office Action mailed December 13, 2007, Applicants submit the following amendments and remarks for entry into the record of this application.

**Amendments to the Claims** are reflected in the listing of claims that begin on page 2 of this paper.

Remarks begin on page 6 of this paper.

A Petition for an Extension of Time for Responding is enclosed.

No fee is believed to be due for the claim changes and additions of this submission. Please charge any and all required fees to enter and process this amendment to **Winston & Strawn LLP** Deposit Account No. 50-1814.